

Notice of References Cited	Application/Control No. 10/725,903		Applicant(s)/Patent Under Reexamination WIENEKE, BERNHARD	
	Examiner Chia-Wei A. Chen		Art Unit 2609	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,789,039 B1	09-2004	Krumm, John C.	702/150
*	B	US-5,699,444	12-1997	Palm, Charles S.	382/106
*	C	US-7,130,490 B2	10-2006	Elder et al.	382/294
*	D	US-5,905,568	05-1999	McDowell et al.	356/28
*	E	US-5,610,703	03-1997	Raffel et al.	356/28
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Walker, Steven. Two-axis Scheimpflug focusing for particle image velocimetry. Aug 2001. Instrumentation in Aerospace Simulation Facilities, 2001. 19th International Congress on ICIASF 2001. pp. 114-124
	V	Meng, Xiaoqiao, Hu, Zhanyi. A new easy camera calibration technique based on circular points. 18 March 2002. The Journal of the Pattern Recognition Society. Volume 36. pp. 1155-1164
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.